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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

**SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT**

Docket Number  
**12992/90501**

Application Number  
**10/824,288**

Filing Date  
**April 13, 2004**

Examiner  
**Not Yet Assigned**

Art Unit  
**2811**

Invention Title  
**METHOD OF FABRICATING AN  
OPTOELECTRONIC DEVICE HAVING A BULK  
HETEROJUNCTION**

Inventor(s)  
**SHTEIN ET AL.**

Address to:

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

Date: 1 Apr. '05 Reg. No. 29,770

Signature: Patrick J. Birde  
Patrick J. Birde

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. The filing of this Information Disclosure Statement and the attached PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
3. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed.
4. It is believed that no fees are due in connection with this Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

Dated: 1 Apr. '05

By:

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

 DOCKET NO.  
12992/90501

 SERIAL NO.  
10/824,288

 APPLICANT  
SHTEIN et al.

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 GROUP  
2811

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	No

**NON PATENT LITERATURE DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	< <a href="http://www.oksolar.com/solar_panels/unisolar_flexibles.htm">http://www.oksolar.com/solar_panels/unisolar_flexibles.htm</a> >, "Uni-solar Flexible (USF) Unbreakable Solar Panels - Triple Junction", printed September 14, 2004.
	"UNI-POWER Solar Electric Modules Specification Sheet, Models US-64, US-42, US-32", printed from the OKSolar.com website on September 14, 2004 < <a href="http://www.oksolar.com/pdf/solar_energy_catalog/unisolar_us-64.pdf">http://www.oksolar.com/pdf/solar_energy_catalog/unisolar_us-64.pdf</a> >.
	"Amorphous Silicon (a-Si) Solar Technology", printed from United Solar Ovonic Corp. website on September 14, 2004, < <a href="http://www.uni-solar.com/Our_Technology_a_Si.html">http://www.uni-solar.com/Our_Technology_a_Si.html</a> >.
	S. Guha, et al., "Amorphous Silicon Alloy Photovoltaic Research Present and Future", Progress in Photovoltaics: Research and Applications, Prog. Photovolt. Res. Appl. 8, pp. 141-150 (2000).

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.